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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/137,629
 Priority Filing Date August 21, 1998
 Inventor David R. Hembree
 Assignee Micron Technology, Inc.
 Priority Group Art Unit 2858
 Priority Examiner V. Nguyen
 Attorney's Docket No. MI22-1684
 Title: "Methods of Processing Wafers and Methods of Communicating Signals With
 Respect to a Wafer"

3503 U.S. PTO
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 E. Willis
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INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a continuation application of co-pending application Serial No. 09/137,629, filed August 21, 1998. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned.

37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 4/2/01

By: [Signature]
 James D. Shaurette
 Reg. No. 39,833